

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

APPLICATION NO.:

Grigorian et al.

FILING DATE:

09/825,870 April 5, 2001

TITLE:

CHEMICAL VAPOR DEPOSITION GROWTH OF SINGLE-WALL

CARBON NANOTUBES

EXAMINER:

Peter J. Lish

GROUP ART UNIT:

1754

ATTY. DKT. NO.:

23085-08328/US

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop After Final, Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below:

Dated:

April 1/2005

By: Marida Davida

Narinder Banait, Reg. No.: 43,482

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AMENDMENT/RESPONSE (37 C.F.R. § 1.116)

SIR:

Responsive to the Final Office Action dated December 1, 2004, received in the above-identified patent application, please enter the following amendments, and consider the accompanying remarks. As the response is being filed after three months of the date of mailing of the Office Action, this Amendment includes a request for an extension of time. Applicants respectfully requests reconsideration of the claims in the above-identified application in view of the following amendments and remarks for the purpose of putting the application in condition for allowance.

04/05/2005 MAHMED1

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